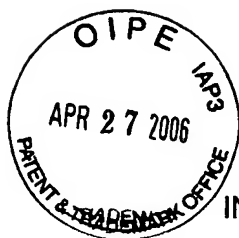


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PATENT  
Customer No. 22,852  
Attorney Docket No. 07942.0013-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Cheng-ta WU et al. )  
Application No.: 10/779,634 ) Group Art Unit: 1754  
Filed: February 18, 2004 ) Examiner: Johnson, Edward M.  
For: SYSTEM AND METHOD FOR )  
PROCESSING RESIDUAL GAS ) Confirmation No.: 9096

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed February 8, 2006, the period for response to which extends through May 8, 2006, please amend the application as follows and reconsider the application in view of the following remarks.

**AMENDMENTS TO THE CLAIMS** are reflected in the claim listing beginning on page 2 of this paper.

**REMARKS** follow the **AMENDMENTS TO THE CLAIMS** section and begin on page 6 of this paper.